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INFORMATION DISCLOSURE STATEMENT							
FOR	A complex membrane for electrochemical device, manufacturing method and electrochemical device having the same						
Application No.	-	Filing Date	-				
Applicant	SAMSHIN CREATION CO., LTD.						
Our Ref.	OV050775US	Your Ref.	-				
U.S. PATENT DOCUMENTS (Not Enclosed)							
Document No.	Date	Inventors	U.S. Class	U.S. Subclass	Remark		
4,994,335	February 19, 1991	Eiichi et al.					
FOREIGN PATENT DOCUMENTS							
Document No.	Date	Country	Class	Subclass	Translation of Abstract		Remark
					Yes	No	
JP 12-212323 A	August 2, 2000	Japan			x		
JP 14-190291 A	July 5, 2002	Japan			x		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							

Examiner: /John Maples/
Signature:

Date: 05/14/2010
Considered: